



AF/ 2851

PATENT

Customer No. 22,852

Attorney Docket No. 04788.0247

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Yasuhiro OMURA

Application No.: 09/865,734

Filed: May 29, 2001

For: PROJECTION OPTICAL SYSTEM,  
EXPOSURE APPARATUS  
INCORPORATING THIS  
PROJECTION OPTICAL SYSTEM,  
AND MANUFACTURING METHOD  
FOR MICRO DEVICES USING  
THE EXPOSURE APPARATUS

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)  
) Group Art Unit: 2851

)  
) Examiner: Hung Nguyen  
)

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicant hereby petitions for a three-month extension of time to reply to the  
Office Action of June 4, 2003. A fee of \$950.00 is enclosed.

Please grant any extensions of time required to enter this response and charge  
any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

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Dated: December 4, 2003

By:

*Doris J. Hines*  
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for Reg. No. 34,629